

Shin-Etsu Chemical Co., Ltd. 6-1 Ohtemachi 2-chome Chiyoda-ku, Tokyo Chihiro Kanagawa Representative Director/ President (Code No. 4063)

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Notice of Personnel Matter Regarding Chairman and President

Shin-Etsu Chemical Co., Ltd. (the "Company") hereby announces that, at the meeting of the board of directors held today, it decided the following matter relating to changes affecting its representative directors.

1. Nature of Change

Name	New Position	Former Position
Mr. Chihiro Kanagawa	Representative Director/ Chairman	Representative Director/ President
Mr. Shunzo Mori	Representative Director/ President	Representative Director/ Executive Vice President

2. Reason for Change

The Company intends to further strengthen its business, as managed by Mr. Kanagawa up to now, and will strive to continue its progress.

The Company's corporate group is extending its profits while solidifying its foundations in its major business areas, and, at the same time, is working to develop new areas of business. We have grown our PVC business, primarily through our U.S. subsidiary Shintech Inc. We have expanded our semiconductor silicon business through large capital investments, while always keeping our eye on the future of this rapidly-changing market. The Company's expansion also incorporates the strength of our other unique products, such as silicone resins, synthetic quartz, rare earth magnets, cellulose derivatives, and photoresists.

The Company will strive to meet its important business goals of increasing sales in developing markets, beginning with China, and contributing to the improvement of the earth's environment.

In this way, the Company will expand its business goals, and it will be necessary to expand our business on a global basis beyond what we have done up to now. The Company will strive to maintain the continued increase in its value by moving ahead with these efforts even further.

3. Planned Date of Change

The Company plans to formally decide this matter at the meeting of board of directors which follows the end of the regular meeting of shareholders scheduled for June 29, 2010.

4. Background of New Chairman and President

Please see attached

Background of New Chairman:

Name: Mr. Chihiro Kanagawa

Date of Birth: March 15, 1926

Education: Graduate, University of Tokyo, Legal Department, Political Science Section

Professional Background:

February 1962 Joined the Company

December 1970 General Manager, International Division

January 1975 Director

August 1976 Managing Director

March 1978 President, Shintech, Inc. (current position)

January 1979 Senior Managing Director

August 1983 Representative Director/Executive Vice President August 1990 Representative Director/President (current position)

June 2010 Representative Director/Chairman (planned)

Background of New President:

Name: Mr. Shunzo Mori

Date of Birth: June 27, 1937

Education: Graduate, Niigata University, Engineering Department, Mechanical

Engineering Section

Professional Background:

September 1963 Joined the Company

May 1985 Director, Shin-Etsu Engineering, Inc.

May 1988 Managing Director, Shin-Etsu Engineering, Inc.

January 1992 General Manager, Takefu Plant

June 1992 Director

June 1996 Managing Director

General Manager, Electronic Materials Department

(current position)

June 1998 Senior Managing Director

November 2001 Director in Charge of General Affairs (current position)

June 2002 Director in Charge of Personnel Matters (current position)

July 2007 Representative Director/Senior Managing Director June 2009 Representative Director/Executive Vice President

(current position)

June 2010 Representative Director/President (planned)